

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DAVID J. BAIN, ET AL.	)
		) Group Art Unit: 2836
Serial No.:	10/710,653	)
		)
Filed:	July 27, 2004	) Examiner: Roman, L.
		)
For:	PRESSURE ASSISTED WAFER	)
	HOLDING APPARATUS AND	) Confirmation No.: 4652
	CONTROL METHOD	)

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Final Office Action mailed August 22, 2007, please amend the  
Application as follows: